

FIG. 1I

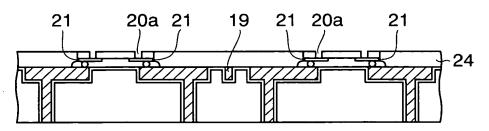


FIG. 1J

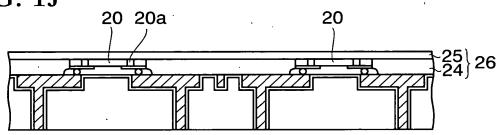
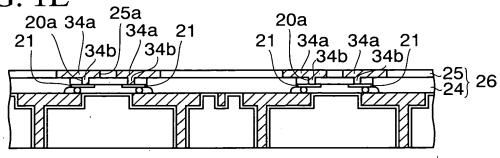
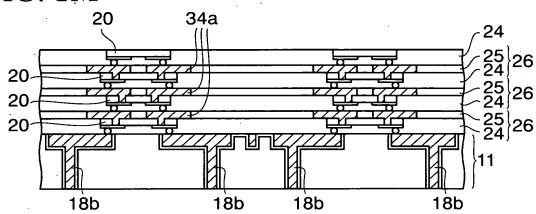


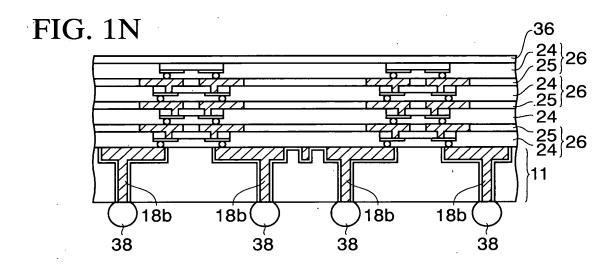
FIG. 1K
A 25a
20a 25
25
24 26

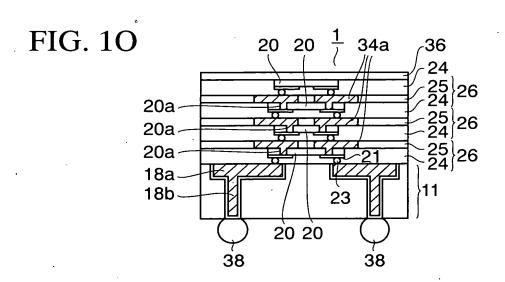


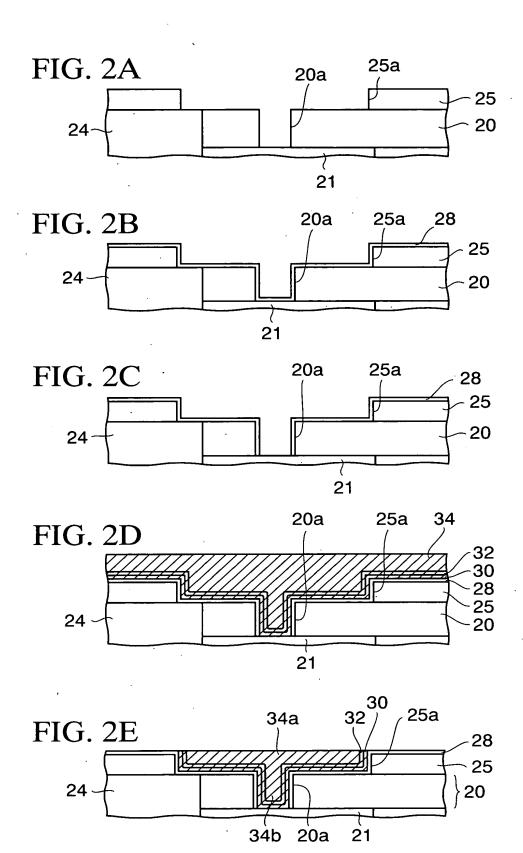






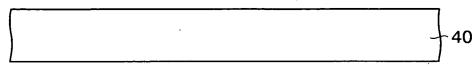


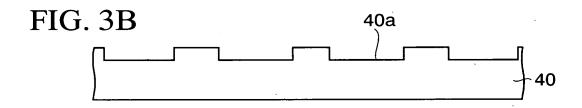


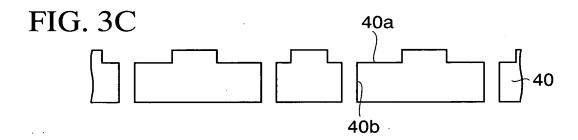


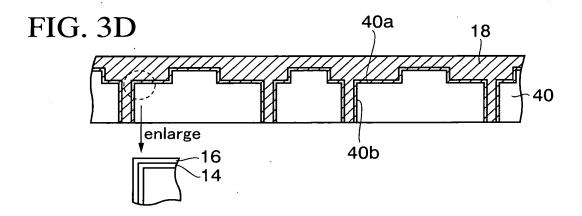
Title: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME
By: Masahiro SUNOHARA
Docket No.: 031256

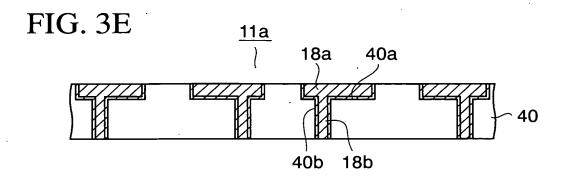


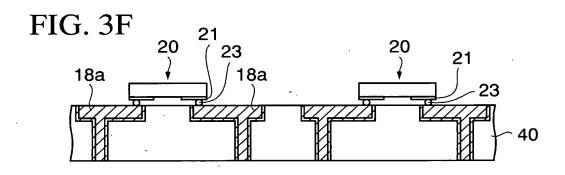


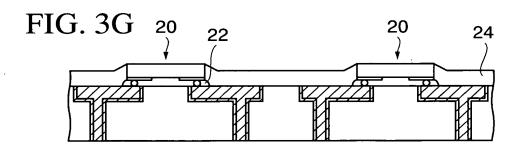


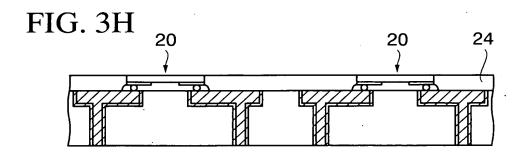












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FIG. 3I

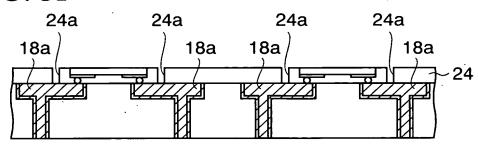


FIG. 3J

24a

24a

24a

24a

25

26

FIG. 3L

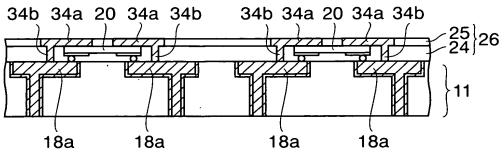


FIG. 3M

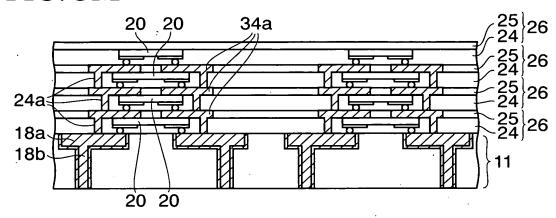
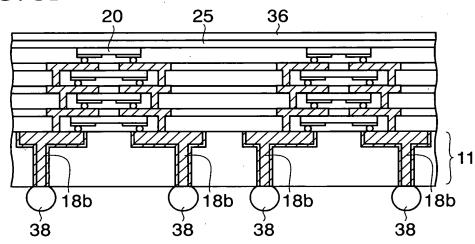
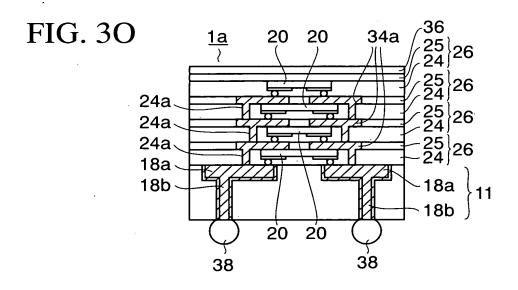
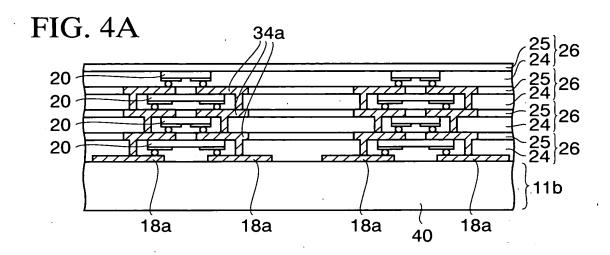
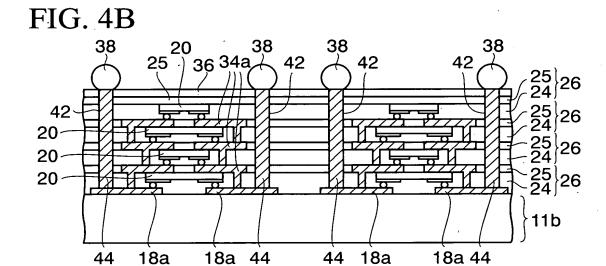


FIG. 3N









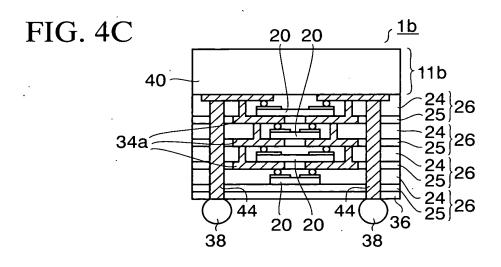
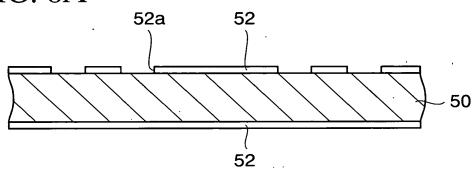
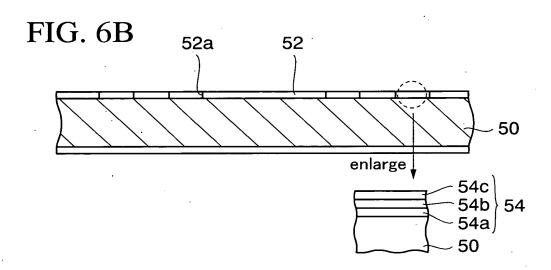
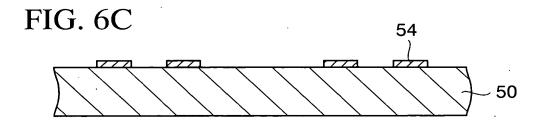


FIG. 5 <u>1c</u> 34a 20 36 24a 24a -24a -18a 10b -18c 24a 24a -24a 24a π 34a 36 38

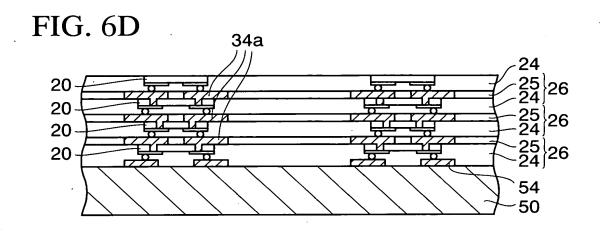
FIG. 6A

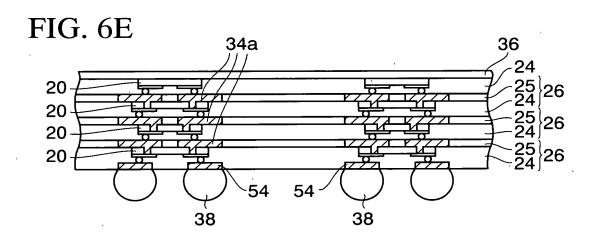


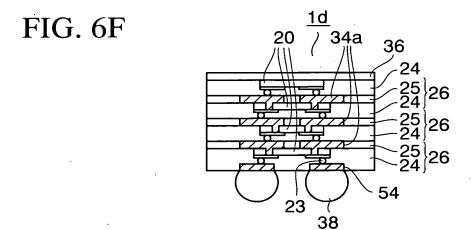




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FIG. 7A

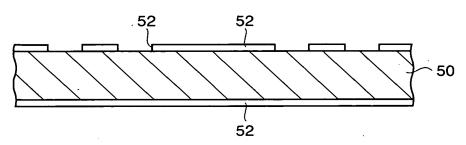


FIG. 7B

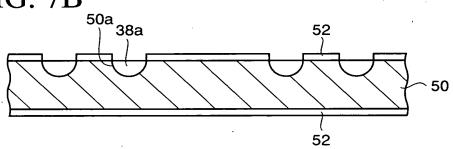


FIG. 7C

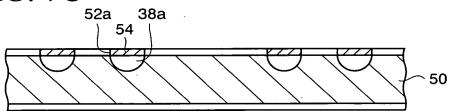


FIG. 7D

